



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/734,419  
Filing Date ..... December 11, 2003  
Inventor ..... John T. Moore et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2815  
Examiner ..... Warren, Matthew E.  
Attorney's Docket No. .... MI22-2463  
Title: Semiconductor Wafer Assemblies Comprising Photoresist Over Silicon  
Nitride Materials

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

To: Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

Dear Sir:

The Examiner's attention is directed to the references which are listed on  
the attached Form PTO-1449.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified  
under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated:

May 19, 2005

By:

Jennifer J. Taylor  
Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711

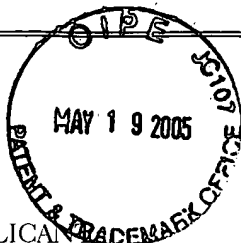
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Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICELIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)ATTY. DOCKET NO.  
MI22-2463SERIAL NO.  
10/734,419APPLICANT  
John T. Moore et al.FILING DATE  
December 11, 2003GROUP  
2815

## U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,756,634	06-2004	Helm et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Classes	Subclass	Translation	
							Yes	No
	AK							
	AL							
	AM							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AN	
	AO	
	AP	
EXAMINER	DATE CONSIDERED	

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.